

Notice of References Cited

Applicant/Patent
Sandhu et al.

Application/Control No.
08/636,069

Examiner

Erik Kielin

Art Unit

2813

Page 1 of 1

U.S. PATENT DOCUMENTS

	Document Number Country Code-Number-Kind Code	Date MM-YYYY ¹	Name	Classification ²
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NON-PATENT DOCUMENTS

	Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages		
U	the article by Inoue et al. entitled, "Growth of SiO ₂ thin film by double-excitation photoinduced chemical vapor deposition incorporated with microwave excitation of oxygen" Journal of Applied Physics 64(11), 1 Dec. 1988.		
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* A copy of this reference is not being furnished with this Office action. See MPEP § 707.05(a).

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² Classifications may be U.S. or foreign.